

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/389,533
 Priority Filing Date September 2, 1999
 Inventor Alan R. Reinberg
 Assignee Micron Technology, Inc.
 Priority Group Art Unit 2823
 Priority Examiner T. Pham
 Attorney's Docket No. MI22-1952
 Title: Methods of Forming Capacitors and Resultant Capacitor Structures

PRELIMINARY AMENDMENT

To: Assistant Commissioner for Patents
 Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

AMENDMENTS

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